



Emalc

Attorney Dkt. No.: 016790-0411

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fritz Juergen HOHN

Title: MICROSCOPE HAVING AN  
ELECTRON BEAM FOR  
ILLUMINATION

Appl. No.: 09/783,308

Filing Date: February 15, 2001

Examiner: N. Wells

Art Unit: 2881

**STATEMENT OF SUBSTANCE OF EXAMINER INTERVIEW**

Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This communication is in response to the Interview Summary mailed March 15, 2004, concerning the above-referenced patent application.

The substance of the interview with the Examiner on March 1, 2004, was amending claims 11 and 13 to add "and, said electron beam objective having a size comparable to an objective of a conventional light microscope."

Respectfully submitted,

Date 4/5/04

FOLEY & LARDNER  
Washington Harbour  
3000 K Street, N.W., Suite 500  
Washington, D.C. 20007-5109  
Telephone: (202) 672-5414  
Facsimile: (202) 672-5399

By Richard L. Schwab  
for Richard L. Schwab  
Attorney for Applicant  
Registration No. 25,479